



Docket No.: 4249-0110P  
(PATENT)

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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In re Patent Application of:  
Ramam AKKIPEDDI et al.

Application No.: 10/602,714

Confirmation No.: 9942

Filed: June 25, 2003

Art Unit: 1765

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For: METHOD OF CLEAVING GaN/SAPPHIRE  
FOR FORMING LASER MIRROR FACETS

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Examiner: S. Ahmed

**AMENDMENT**

MS RCE  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

INTRODUCTORY COMMENTS

Prior to further examination on the merits, please amend the above-identified U.S. patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 7 of this paper.